

Search Notes

Application/Control No.

10/629,543

Examiner

CHAMELI C. DAS

Applicant(s)/Patent under
Reexamination

HA, CHANG JIN

Art Unit

2192

SEARCHED

| Class | Subclass | Date | Examiner |
|-------|-----------------|----------|----------|
| 717 | 168-173, 174 | 3/9/2006 | CD |
| 717 | 124 | 3/9/2006 | CD |
| 711 | 102-104 | | |
| 700 | 81 | | |
| 713 | 2 | | |
| | | | |
| | | | |
| | | | |
| | | | |
| | | | |
| | | | |
| | | | |
| | | | |
| | | | |
| | | | |

INTERFERENCE SEARCHED

| Class | Subclass | Date | Examiner |
|-------|----------|------|----------|
| | | | |
| | | | |
| | | | |
| | | | |

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

| | DATE | EXMR |
|---|----------|------|
| Search for double patenting WEST - USPATFILE - USPGPUB - US OCR - JPO ABS - EPO ABS - DWPI - IBM TECH | 3/9/2006 | CD |
| ACM IEEE | 3/9/2006 | CD |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |